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Name (line 1) Novellus Systems, Inc.

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Name (line 2)

Second Party

Name (line 1)

Execution Date  
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Receiving Party

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Name (line 1) UVTech Systems, Inc.

Name (line 2)

Address (line 1) One Longfellow Center

Address (line 2) 526 Boston Post Road

Address (line 3) Wayland

Massachusetts

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City

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Zip Code

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Area Code and Telephone Number

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Patent Application Number(s)

Patent Number(s)

5,669,979

60/260,279

5,814,156

09/736,073

If this document is being filed together with a new Patent Application, enter the date the patent application was

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Patent Cooperation Treaty (PCT)

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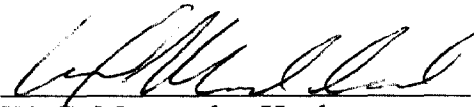
For valuable consideration, Novellus Systems, Inc., a California corporation having its principal place of business at 4000 N. First Street, San Jose, CA 95134, the assignee of United States Patent No. 5,669,979, United States Patent No. 5,814,156, United States Patent Application Serial No. 09/736,073, and United States Patent Application Serial No. 60/260,279, (hereinafter "the Licensor") hereby grants to UVTech Systems, Inc., a Massachusetts Corporation having its principle place of business at One Longfellow Center, 526 Boston Post Road, Wayland, MA 01778, and its successors (collectively hereinafter called "the Licensee"), an exclusive, royalty-free, transferable, sublicensable, worldwide license to make and to have made, market, distribute, exploit, sell, offer to sell, and import products using or incorporating the inventions which are the subject of United States Patent No. 5,669,979 entitled "Photoreactive Surface Processing", United States Patent No. 5,814,156 entitled "Photoreactive Surface Cleaning", United States Patent Application Serial No. 09/736,073 entitled "Scanning Plasma Reactor", and United States Patent Application Serial No. 60/260,279 entitled "Predictive Model for Photoreactive Cleaning" solely in the areas of non-integrated circuit technology (including, without limitation, compact discs, CD stampers, CD masters, thin film heads, flat panel displays, medical instruments, magnetic tape, coated films, all continuous roll-to-roll applications, printed circuit boards without integrated circuit chips on them, digital mirrors, optical media, and optical elements, or extensions to the foregoing technologies to the extent that they do not incorporate or encompass integrated circuit technology or extensions thereof);

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In Witness Whereof, I hereto set my hand and seal at SAN JOSE, CA  
this 14 day of SEPTEMBER, 2001.

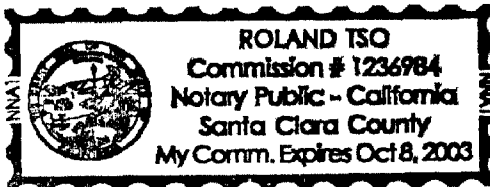
  
W. G. M. van den Hoek  
Executive Vice President  
Novellus Systems, Inc.

State of California }  
County of Santa Clara }

Before me this 14 day of September, 2001, personally appeared W. G. M. van den Hoek known to me to be the person whose name is subscribed to the foregoing assignment and acknowledged that he executed the same as his free act and deed for the purposes therein contained.

[Notary's  
seal here]

UV-100J





Notary Public

My commission expires: Oct-8, 2003

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